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520.35237VX3



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

T. KAJI, et al.

**Application No.:** 

10/052,538

Filed:

January 23, 2002

For:

PLASMA PROCESSING APPARATUS PROCESSING

**METHOD** 

Art Unit:

1763

Examiner:

A. M. Crowell

## **SUPPLEMENTAL AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 July 16, 2004

Sir:

In supplement to the Amendment filed July 6, 2004, please further amend the above-identified application as follows:

Amendments to the Claims and

Remarks are included following the amendments.